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AF 12815  
RESPONSE UNDER 37 C.F.R. § 1.116  
EXPEDITED PROCEDURE  
GROUP 2815  
PATENT APPLICATION

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of

Docket No: Q63936

Makoto NONAKA

Appln. No.: 09/823,752

Group Art Unit: 2815

Confirmation No.: 9106

Examiner: George C. ECKERT II

Filed: April 03, 2001

For: SEMICONDUCTOR DEVICE AND METHOD OF FABRICATING THE SAME

**RESPONSE UNDER 37 C.F.R. § 1.116**

**MAIL STOP AF**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated August 6, 2003, please consider the remarks as submitted herewith on the accompanying pages.

**REMARKS**

Applicant thanks the Examiner for considering the references cited with the Information Disclosure Statement filed April 21, 2003.

**Status of the Application**

Claims 3, 8-16, 24-26 and 30 are all the claims pending in the Application. Only claims 3 and 24-26 have been rejected.

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